	Application/Control No.	Applicant(s)/Patent under Reexamination	
ĺ	10/573,897	KAWARAI ET AL.	
	Examiner	Art Unit	
	Noah Kamen	3747	

	SEARCHED				
Class	Subclass	Date	Examiner		
123	184.21	4/10/07	K		
	184.57				
	198É				
181	229	·			

INT	INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner			
see	EAST	4/10/2007	pK			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
		DATE	EXMR	
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